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Metal Oxide Coated Porous Silicon Electrode Fabricated by Anodized Liquid Phase Depositions

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The titanium oxide/PSi nanocomposite was fabricated by liquid phase deposition (LPD) method with applying anodic potential. Results of SEM-EDX measurement showed that TiO$_2$ deposited into the fine pore (ca. 7.4 nm) only when oxidized PSi surface was used as F$^-$ scavenger or PSi was anodized under the existence of titanium ions. TiO$_2$/PSi nanocomposite was fabricated by anodization of PSi in H$_2$TiF$_6$ electrolyte under constant potential. As the amount of Ti maximized at 300 mV vs. Ag/AgCl, deposition process can be controlled by applied potential in this method. The charge/discharge capacities were measured for fabricated TiO$_2$/PSi as lithium-ion battery anode. The improvement of the capacity was derived from the increase in PSi wettability by TiO$_2$ deposition and activation of silicon in fine structure. In addition, TiO$_2$/PSi fabricated by anodization kept higher capacity without rapid degradation, because of free from SiO$_2$.

Introduction

Porous silicon, PSi, is fabricated by silicon anodization in etching solution (1), stain etching (2,3), and metal-assisted chemical etching (4,5). In addition, PSi can be also fabricated by a silicon wafer anodization in HF aqueous solution. PSi formation via anodization is controllable by change of the type and concentration of dopant in silicon wafer, HF$^-$ concentration in etching solution and current density, and various pores can be formed. We attempted to deposit TiO$_2$ on PSi, which was formed by the LPD method which is effective for deposition of TiO$_2$ on PSi substrate having submicron ordered pores. SiO$_2$ generated by thermal oxidation of PSi substrate and silicon surface at anodic potential can be the candidates for F$^-$ scavengers when attempting to deposit on TiO$_2$ on PSi by the LPD method. Therefore anodization of PSi in the LPD reaction solution is expected to be an easy process for fabrication of TiO$_2$/PSi nanocomposite. In this study, TiO$_2$/PSi nanocomposites were fabricated with the use of boric acid, oxidized PSi surface or silicon surface at anodic potential as an F$^-$ scavenger.

TiO$_2$/PSi nanocomposites which were prepared by the LPD method are quite useful for lithium ion battery (LIB) anodes. Titanium oxide absorbs lithium ion as following reaction:

$$\text{TiO}_2 + \chi\text{Li}^+ + \chi\text{e}^- \leftrightarrow \text{Li}_\chi\text{TiO}_2$$ (1)

When TiO$_2$ electrode is used as LIB anode, the theoretical capacity is 170 mAh·g$^{-1}$ and operating voltage is 1.75 V vs. Li$^+$/Li (6,7). Therefore, it can be estimated that TiO$_2$...
electrode is inferior as compared with graphite (372 mAh·g⁻¹) from the aspect of capacity and energy density. However TiO₂ can absorb lithium with small volume change, thus TiO₂ can be the prominent anode material with the object to cycle property and safety. We attempted to deposit TiO₂ on Porous silicon (PSi) which has low resistivity (3.0-4.0 mΩ·cm) by the LPD method and fabricate TiO₂/PSi nanocomposite. Nanocomposites were fabricated by the LPD method with various F⁻ scavengers, and some of them held fine pores derived from PSi substrate and TiO₂ covered a part of PSi surface.

Silicon substrate also can be active material for LIB anode when fabricated TiO₂/PSi nanocomposites were use as electrode.

\[
\text{Si} + 4.4\text{Li}^+ + 4.4\text{e}^- \leftrightarrow \text{Li}_{4.4}\text{Si} \tag{2}
\]

It is well known that one silicon atom can absorb 4.4 lithium ions when silicon is used as LIB anode material, and the theoretical capacity of silicon is very large (ca. 4200 mAh·g⁻¹). In addition, the operating voltage of silicon is 0.0-0.4 V vs. Li⁺/Li(8-10), which is relatively close to that of a lithium electrode, thus high energy density is expected. Besides, it is expected that the usage of PSi instead of silicon wafer enables electrode to perform high-speed charge/discharge and high-capacity charge which are derived from the large surface area. On the other hand, there is a disadvantage, that is, PSi causes high hydrophobicity because of its terminal group and lotus effect derived from fine structure(11). This indicates that silicon in porous layer does not work as an active material, and first charge capacity may decrease. The deposition of TiO₂ on the surface of PSi pore is effective method to solve the issue. Since TiO₂ is lithium storage material as well as superhydrophilic material, it is expected that effective surface area of PSi for electrode increase by deposition of TiO₂. In this study, TiO₂/PSi nanocomposites were used as LIB anode. The half-cell electrochemical measurements were performed with beaker cell.

**Experimental**

**Fabrication of porous silicon(PSi)**

Highly boron doped P-type single crystal (100) silicon wafer (Shin-Etsu Astech Co., Ltd.) was used as the working electrode. The thickness of silicon wafer was 625.0 ± 25.0 µm, and the resistivity of that was 3.00 - 4.00 mΩ·cm. Silicon wafer was cut into the size of 2 × 2 cm² with a diamond cutter. These were dipped in acetone and cleaned ultrasonically for 15 min to degrease, and taken out from acetone and dried at room temperature. The electrolysis cell made from Teflon® was prepared, and silicon wafer working electrode and platinum mesh counter electrode were fixed at the electrolysis cell. After 5 min of introduction of 5 wt% HF aqueous solution, 5 wt% HF aqueous solution was removed and HF/H₂O/EtOH mixed solution was introduced. The cell filled with the electrolyte was moved to dark room at room temperature, and the anodic oxidization of silicon electrode was carried out under galvanostatic condition (60 mA·cm⁻²) for 10 min. The electrolyte was removed after the anodic oxidization. The silicon electrode was rinsed with deionized distilled water and methanol, and dried in Ar atmosphere at room temperature. The characterization of PSi was carried out by FE-SEM and the determination of the surface area and the pore size distributions with N₂-isotherm analysis.
Deposition of TiO$_2$ on silicon wafer or PSi by the LPD reaction with anodized Si as F$^-$ scavenger

Silicon wafer or PSi working electrode, platinum mesh counter electrode, Ag/AgCl reference electrode and salt bridge were fixed in a three-electrode electrolysis cell. H$_2$TiF$_6$/H$_2$O/EtOH mixed solution was used as an electrolyte. Silicon working electrode was anodized in the electrolyte at constant potential (0-550 mV vs. Ag/AgCl). The reaction was performed for 30 min at room temperature. After anodization the working electrode was removed from solution and rinsed with deionized distilled water and methanol. The sample was dried in Ar atmosphere at room temperature. The characterization of TiO$_2$ thin film on silicon wafer was carried out by FE-SEM, XRD, FT-IR. The surface area was measured by multipoint BET method and the deposition amount of titanium was quantified by ICP-AES.

Electrochemical properties evaluation as an anode of lithium-ion battery

Lithium ribbon (Aldrich chemistry) stored in hexane was cut into $1 \times 2$ cm$^2$ rectangle, which was adequately rinsed with 1.0 mol·dm$^{-3}$ LiClO$_4$-EC/DEC electrolyte and used as Li electrode. As-prepared PSi was thermally oxidized at 300 °C for 4 min in air(12) by muffle furnace (KOYO Thermo Systems Co., Ltd). This oxidized PSi (SiO$_2$/PSi) was used as the electrode for reference measurement. The cyclic voltammetry measurements were performed to confirm the potential response between electrode and lithium ions by CompactStat-CompactStatPlus (Ivium technologies). The measurement was performed in the region of 0-3.0 V vs. Li$^+$/Li at 0.5 mV·s$^{-1}$ sweep rate. The evaluation of charge/discharge capacity of each sample was performed. Charge/discharge was performed at 500 µA for each sample, and cut-off voltage was set to 0.01-3.50 V vs. Li$^+$/Li. Charge/discharge was repeated at most 15 times. The sample was arbitrarily taken out on the course of charge/discharge, rinsed with methanol (Nacalai tesque Inc.) and dried in Ar atmosphere. The sample was evaluated by other instruments. The morphology and the oxidation state on the surface of the fabricated TiO$_2$/PSi caused by charge/discharge were observed by FE-SEM and XPS, respectively.

Results and discussion

Fabrication of TiO$_2$/PSi nanocomposites by the LPD method

The silicon wafers were successfully anodized in HF/H$_2$O/EtOH mixed solution under a constant current which was 60 mA·cm$^{-2}$ for 10 min. The depth of pore was about 27.7 µm, and the pore size distributions suggested that the electrochemically dissolved sample was uniform porous material which had fine pores with about 7.3 nm diameter. The surface area of PSi was 0.864 m$^2$ from the result of multipoint BET method. It was obvious that the surface structure of the sample has been complicated by etching process. PSi was immersed in (NH$_4$)$_2$TiF$_6$/H$_3$BO$_3$ or H$_2$TiF$_6$/H$_3$BO$_3$ mixed solution in which boric acid was used as F$^-$ scavenger, and the LPD reaction was continued for 1 or 6 h. Fig. 1 shows SEM images and SEM-EDX line mappings for titanium of these samples. Top surface image showed that the mesopores derived from PSi substrate disappeared in the sample immersed in (NH$_4$)$_2$TiF$_6$/H$_3$BO$_3$ mixed reaction solution for 6 h. Furthermore, titanium was located on top of the porous layer as observed cross section SEM-EDS
measurement about the same sample. Thus, it can be estimated that the reason for disappearance of mesopores was the covering of substrate by deposited titanium oxide. In addition, it was observed that this titanium oxide deposited only out of the porous layer, and did not deposit in the pores. This phenomenon was caused by the poor wettability of PSi which disturbed reaction solution to intrude into porous layer(11). The deposition of titanium oxide was not observed from the PSi immersed in H$_2$TiF$_6$/H$_3$BO$_3$ mixed reaction solution. The pH of H$_2$TiF$_6$/H$_3$BO$_3$ mixed reaction solution was lower than that of (NH$_4$)$_2$TiF$_6$/H$_3$BO$_3$ mixed reaction solution and the increase in activity of F ions disturbed the hydrolysis reaction for the LPD method.

In order to improve the wettability of PSi surface or form SiO$_2$ layer used as F scavenger, as-prepared PSi was thermally oxidized(12). Fig. 2 shows SEM images and
SEM-EDS line profile for titanium of samples. SEM-EDS measurements for all samples indicated that titanium oxide was deposited in porous layer. These results were extremely different from those of non-oxidized PSi substrates. It was supposed that the difference was derived from the existence of silicon terminal groups (Si-H). The surface with Si-H group is known to work as a water shedding surface. In addition it is reported that Si-H group prevents fluorine to etch the silicon(11,13). Therefore, the PSi oxidation process at high temperature changed Si-H group to silanol group, which was active as F- scavenger and made it possible for reaction solution to intrude into porous layer. When thermally oxidized PSi substrate was immersed in (NH$_4$)$_2$TiF$_6$/H$_3$BO$_3$ mixed reaction solution, titanium oxide filled the pores and deposited out of the porous layer (Fig. 2(a)). This was because titanium oxide core was generated by hydrolysis in bulk liquid with high speed due to high pH and boric acid. On the other hand, SEM observation suggested that PSi substrate structure was held even after the LPD reaction and titanium oxide was deposited on the wall surface in other systems. Since SiO$_2$ on the PSi surface was used as F- scavenger in (NH$_4$)$_2$TiF$_6$ reaction solution and H$_2$TiF$_6$ reaction solution, the mean free pass of titanium oxide core generated by hydrolysis was quite short, thus on-site deposition of titanium oxide was performed. The XPS measurements were also supported these phenomena.

Therefore we also evaluated the novel nanocomposite fabrication process by the anodizations of the silicon wafer and PSi with the LPD reaction. The anisotropic etching will be preferred for the fabrication of the fine structured nanocomposites. Hence, we attempted to anodize silicon or PSi at the potential which caused nano-PSi formation or anisotropic etching (0-500 mV vs. Ag/AgCl) and fabricate nanocomposites. Before the formation of TiO$_2$/PSi nanocomposite, silicon wafer was used as an electrode and titanium oxide deposition on silicon wafer was attempted by anodization at 100-500 mV vs. Ag/AgCl. Fig. 3 shows the XPS spectra in range of Ti 2p about silicon wafer anodized at 100-500 mV vs. Ag/AgCl for 30 min in H$_2$TiF$_6$/H$_2$O/EtOH mixed solution. The peaks derived from titanium were observed from almost all samples, and especially the peaks of anodized sample at 300 or 400 mV vs. Ag/AgCl were shifted to low binding energy side (ca. 459.7 eV). It was suggested that titanium becomes chemically bonded to silicon substrate after considering the very flat substrate surface, washing process and XPS peak shift. Therefore it was indicated that the LPD reaction with the use of silicon at anodic potential was expected to be the novel candidate for nanocomposite fabrication.
process. Fig. 4 shows SEM image and SEM-EDS line mapping for titanium of PSi anodized at 400 mV vs. Ag/AgCl for 30 min in H$_2$TiF$_6$/H$_2$O/EtOH mixed solution. The top surface observation confirmed that the fine pores with about 10 nm diameter were remained even after anodization. In addition, the SEM-EDS mapping indicates that the titanium oxide deposited in the porous layer. Therefore it was suggested that the on-site deposition of titanium oxide was successfully fabricated by the LPD method with the silicon at anodic potential as F$^-$ scavenger. The pore size distributions of PSi anodized at various potential were measured with N$_2$-desorption isotherm. The pore diameter increased with an increasing of the applied potential, and the pore diameter of the nanocomposites fabricated by anodization of PSi for 30 min at 200-500 mV vs. Ag/AgCl were about 9.5 nm, thus, it is obvious that the pore wall was etched during the LPD reaction. Fig. 5 shows the FT-IR results of PSi anodized at constant potentials for 30 min in H$_2$TiF$_6$/H$_2$O/EtOH mixed solution. Three absorption bands at about 2100 cm$^{-1}$ which were observed for all samples can be assigned to SiH$_3$ (2137 cm$^{-1}$), SiH$_2$ (2113 cm$^{-1}$) and SiH (2086 cm$^{-1}$) stretching mode, and the absorption band at about 908 cm$^{-1}$ can be assigned to SiH$_2$ bending mode(14-16). On the other hand, the very weak $\nu_{SiO2}$ absorption band (1878 cm$^{-1}$) and the stretching vibration of Si-O-Ti$^{4+}$ bond structure (940 cm$^{-1}$) were also observed in nanocomposites(17). These results indicate that the chemical bonds between titanium and the substrates were formed by anodization of PSi. Fig. 6(a) shows in the Ti 2p region of the XPS spectra of PSi which was anodized at 400 mV vs. Ag/AgCl for 30 min in H$_2$TiF$_6$/H$_2$O/EtOH mixed solution. H$_2$TiF$_6$ on silicon wafer was used as a reference sample for titanium peak shift. The peak at 460.0 eV is Ti 2p$^{3/2}$ in
reference sample, and the peak at 459.7 eV can be assigned the nanocomposite fabricated by the anodization in \( \text{H}_2\text{TiF}_6/\text{H}_2\text{O/EtOH} \) mixed solution. The peak top position shifted to the lower binding energy by the anodization. The removal of F\(^-\) ions and coordination of O\(^2-\) ions were occurred in these systems, that is, the LPD reaction was brought about. Fig. 6(b) shows XPS in the Si 2p region of the XPS spectra of the same sample and as-prepared PSi as a reference sample. While the peak which was derived from SiO\(_2\) at 103.3 eV was observed from nanocomposites fabricated via thermal oxidation by XPS measurement, the same peak was hardly observed from nanocomposites fabricated via anodic oxidation. SiO\(_2\) formed as an intermediate is supposed to be dissolved by F\(^-\) ions immediately. Finally the quantification of the deposition amount of titanium oxide was performed about nanocomposites fabricated by anodization of PSi at constant potential in \( \text{H}_2\text{TiF}_6/\text{H}_2\text{O/EtOH} \) mixed solution for 30 min, and the result is shown in Fig. 7. The amount of titanium shows the local maxima at applied potential 300 mV vs. Ag/AgCl. This behavior was similar to that of the systems in which SiO\(_2\) on the surface

![XPS spectra for Ti 2p and Si 2p](image)

Fig. 6 XPS spectra for (a) Ti 2p and (b) Si 2p. (i): TiO\(_2\)/PSi fabricated by anodization, applied potential: 400 mV vs. Ag/AgCl, LPD reaction time: 30 min, (ii): silicon wafer on which \( \text{H}_2\text{TiF}_6 \) was dipped and dried, and (iii) as-prepared PSi.

![Applied potential dependence of deposition amount of titanium and substrate weight loss](image)

Fig. 7 Applied potential dependence of deposition amount of titanium and substrate weight loss. LPD reaction time: 30 min.
of PSi was used as F$^-$ scavenger. Thus it was suggested that the behavior was derived from the competition reaction of the titanium fluoro-complex hydrolysis and anodized PSi dissolution. In other words, the poor F$^-$ scavenger disturbed the LPD reaction at low potential, and the substrate dissolution disturbed the LPD reaction at high potential. This consideration was also supported by the observation of substrate weight loss as shown in Fig. 7. The nanocomposite fabricated by anodization at 300 mV vs. Ag/AgCl presented the largest amount of titanium deposition (3.02×10$^{-6}$ mol·m$^{-2}$).

**Electrochemical properties of TiO$_2$/PSi nanocomposites as an anode of Li-ion battery**

Fig. 8 shows the result of the cyclic voltammograms (CV) of PSi, TiO$_2$/PSi(LPD-SiO$_2$) and TiO$_2$/PSi(LPD-anodized Si). At about 0.2 mA peak derived from the lithium insertion was observed in the region of 0.0-0.8 V vs. Li$^+/Li$ from no-TiO$_2$ fabricated PSi.

Fig. 8 Cyclic voltammograms of (1)PSi, (2)TiO$_2$/PSi(LPD-SiO$_2$) and (3)TiO$_2$/PSi(LPD-anodized Si) measured in the range of 0.0 -3.0 V vs. Li/Li$^+$ at 0.5 mV·s$^{-1}$.

On the other hand, the very broad peaks, which were thought to be derived from lithium insertion, were observed around the region of 0.5, 1.5 V vs. Li$^+/Li$ from TiO$_2$/PSi nanocomposites. These CV curves indicated that fabricated TiO$_2$/PSi nanocomposites showed larger current derived from lithium insertion/extraction compared with non-TiO$_2$ fabricated PSi because of the improvement of the wettability and the increase in effective area for LIB anode. In addition, it was obviously observed that lithium was inserted in the range of 1.5 V vs. Li$^+/Li$ and extracted in the range of 2.0 V vs. Li$^+/Li$ as for TiO$_2$/PSi(LPD-anodized Si). These peaks at 1.5 V and 2.0 V vs. Li$^+/Li$ were supposed to come from lithium insertion/extraction of TiO$_2$. Thus it was suggested that TiO$_2$ was under favorable environment to accept electron in TiO$_2$/PSi (LPD-anodized Si), in other words, most of TiO$_2$ existed not on SiO$_2$ insulator but on silicon semiconductor. While TiO$_2$/PSi(LPD-anodized Si) showed large current value in the region where lithium ions were extracted, PSi and TiO$_2$/PSi(LPD-SiO$_2$) showed small current value in the region.

The charge/discharge capacity measurements for each sample were performed on the voltage range of 0.01-3.50 V vs. Li/Li$^+$ at 500 µA. PSi showed 550 µAh of the first charging capacity by charge/discharge at 500 µA, and the capacity gradually decreased with charge/discharge cycles. Finally charging capacity of 15th cycle was 200 µAh.
TiO$_2$/PSi(LPD-SiO$_2$) and TiO$_2$/PSi (LPD-anodized Si) showed 850 µAh and 1700 µAh of the first charging capacity, respectively. These values were higher than that of PSi electrode, and it was suggested that the increase in the first capacity was derived from the improvement of the wettability by the deposition of TiO$_2$ and the activation of silicon in fine pore for LIB anode. This result shows good agreement with the CV measurements. However it was observed that rapid degradation of capacity occurred about TiO$_2$/PSi(LPD-SiO$_2$) after the first charging as can be seen in Fig. 9. This result also supported the CV measurements result in which lithium insertion current increased and extraction current did not increase. The reason can be presumed the deterioration of the substrate structure or the irreversible reaction of lithium in the first charging process. On the other hand, when TiO$_2$/PSi(LPD-anodized Si) was used as electrode, the rapid degradation of capacity was not observed, unlike TiO$_2$/PSi(LPD-SiO$_2$). The capacity gradually decreased with charge/discharge cycles, and the finally charging capacity of the 15th cycle was 200 µAh, and it was similar to that of no-TiO$_2$ fabricated PSi. Therefore it was suggested that one of the reason of the decrease in a capacity was detachment of TiO$_2$ caused by the charge/discharge as for TiO$_2$/PSi(LPD-anodized Si). This consideration was supported by the decrease in 1.0-1.5 V vs. Li$^+$/Li charging region where lithium thought to be inserted into TiO$_2$ with cycles. This hypothesis also supports that the silicon is well known to expand by the insertion of lithium(18). SiO$_2$/PSi showed 1280 µAh of the first charging capacity at 500 µA and rapid degradation of the capacity after the first charging as with TiO$_2$/PSi(LPD-SiO$_2$) as can be seen Fig. 9. This fact strongly supported that rapid capacity degradation of TiO$_2$/PSi(LPD-SiO$_2$) was related to the existence of SiO$_2$ in the electrode.

Fig. 10 shows the SEM images of PSi, TiO$_2$/PSi (LPD-SiO$_2$) and TiO$_2$/PSi (LPD-anodized Si) after 15th charge/discharge. The surface morphology of TiO$_2$/PSi (LPD-SiO$_2$) was quite different from other samples. The crack was not observed on porous layer even after the 15th charge/discharge in PSi and TiO$_2$/PSi(LPD-anodized Si), therefore it was supposed that the deterioration of structure was one of the factors which caused rapid capacity degradation of TiO$_2$/PSi(LPD-SiO$_2$). XPS measurement was

Fig. 9 Charge/discharge curves of each sample on the voltage range of 0.01-3.50 V vs. Li/Li$^+$ at 500 µA at the second cycles. (1) PSi, (2) TiO$_2$/PSi(LPD-SiO$_2$), (3) TiO$_2$/PSi(LPD-anodized Si), and (4) SiO$_2$/PSi.
performed to investigate the oxidation states of PSi in the charge/discharge process. As-prepared, after the first charged and after the first charge/discharged PSi were used as samples. Fig. 11 shows the results of Si 2p and Li 1s measured by XPS. The storage of lithium can be confirmed from the full charged PSi because of the detection of the peak at 57.2 eV in the region of Li 1s. The peak at 104.4 eV was observed as well as the peak derived from Si$^0$ (99.6 eV) in the region of Si 2p from the same sample. However, the peak at 104.4 eV was unclear in spite of our expectation which this peak was related to silicon affected by carbon (19). Furthermore, the peak in Li 1s region disappeared after discharge, thus it was suggested that lithium was extracted from silicon again by discharging. Although we could not detect the peak derived from lithium-silicon alloy in Si 2p region, it was confirmed that ionized lithium existed in electrode because of comparison with the peak derived from lithium metal.

![Fig. 10 SEM images after 15th charged/discharged](image)

Fig. 10 SEM images after 15th charged/discharged (a): PSi, (b): TiO$_2$/PSi(LP-D-SiO$_2$), (c): TiO$_2$/PSi(LP-D-anodized Si) at 500 µA.

![Fig. 11 XPS spectra](image)

Fig. 11 XPS spectra for (a)Si 2p and (b) Li 1s of PSi on the process of charge/discharge. (1): As-prepared, (2): charged, and (3) discharged.

Fig. 12 shows the XPS spectra for TiO$_2$/PSi(LP-D-SiO$_2$). It was observed that the new peaks emerged in the lower binding energy region of Ti 2p as for 300 µAh charged
TiO$_2$/PSi(LP-D-SiO$_2$). This indicated that the part of tetravalent titanium in TiO$_2$ was reduced to trivalent titanium during charging process. Therefore, it was suggested that lithium was inserted into TiO$_2$, as expressed in reaction (1), until the potential reached to ca. 0.8 V vs. Li$^+$/Li in charge process. Since the trivalent titanium was oxidized to tetravalent titanium after discharge, TiO$_2$ is seemed to react with lithium reversibly. However the peak intensities derived from the titanium in the charged/discharged sample were lower than those in the as-prepared sample. It was suggested that TiO$_2$ in TiO$_2$/PSi was detached by the silicon substrate volume with the lithium insertion and extraction, thus the amount of TiO$_2$ decreased. In addition, the peak at 57.2 eV in Li 1S region was observed after the full charge. This indicates that lithium is inserted into TiO$_2$/PSi(LP-D-SiO$_2$). However this peak remained even after discharge. This behavior is quite different from the result of the no-TiO$_2$ fabricated PSi as shown in Fig. 11, and it was suggested that lithium was not extracted from TiO$_2$/PSi(LP-D-SiO$_2$) by discharging. The reason of this phenomenon was thought to be residual SiO$_2$ in TiO$_2$/PSi (LP-D-SiO$_2$). Therefore lithium inserted into the electrode irreversibly reacted with SiO$_2$ as following reaction(20);

$$2\text{SiO}_2 + 4\text{Li} \rightarrow \text{Si} + \text{Li}_4\text{SiO}_4$$

SiO$_2$ remained in the nanocomposite fabrication process, and caused rapid degradation of capacity after first charge.

**Conclusions**

In this study, TiO$_2$/PSi composites were fabricated by the LPD method. The hydrolysis of metal fluoro-complex was promoted by various F- scavengers, i.e. boric acid and silicon dioxide which were generated by the thermal oxidization and the anodized silicon. On-site deposition of TiO$_2$ was especially observed from the composites fabricated by solid F scavengers like SiO$_2$ and anodized silicon. These samples held large surface area derived from PSi substrate. Thus it was suggested that novel LPD method without boric acid was effective for fabrication of TiO$_2$/PSi nanocomposites. Furthermore, the electrochemical properties for LIB anode of TiO$_2$/PSi nanocomposites fabricated by the LPD method were confirmed. The poor wettability of PSi was improved by the
deposition of TiO$_2$ on a surface of the nano-ordered fine structure in the PSi. When TiO$_2$/PSi nanocomposites were used as electrode, silicon in fine pore also worked as an active material and the capacity increased dramatically by the improvement of the wettability. However, in the case of the SiO$_2$ which was prepared by the conventional LPD method, the SiO$_2$ in the fabricated nanocomposite and the SiO$_2$ irreversible reaction with lithium brought about the rapid capacity degradation when used as LIB anode. Silicon surface at anodic potential was used as F$^-$ scavenger in the novel LPD method, and it is the new TiO$_2$/PSi fabrication method which is free from SiO$_2$ insulator. TiO$_2$/PSi fabricated by the novel LPD method actually showed high capacity and reversible reaction, although the electrode exhibits capacity decrease typical of silicon based anodes.

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